

Reg No.: _____

Name: _____

APJ ABDUL KALAM TECHNOLOGICAL UNIVERSITY
SIXTH SEMESTER B.TECH DEGREE EXAMINATION(S), DECEMBER 2019

Course Code: AE364
Course Name: MEMS/NEMS

Max. Marks: 100

Duration: 3 Hours

PART A*Answer any two full questions, each carries 15 marks.*

Marks

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| 1 | a) Write down the advantages of miniaturization of MEMS devices. | (4) |
| | b) Explain scaling in rigid body dynamics using Trimmer Force scaling vector. | (6) |
| | c) Write short notes on the different materials used in MEMS industry. | (5) |
| 2 | a) What is the main advantage of DRIE process and how it is achieved? | (6) |
| | b) List any four applications of MEMS devices. | (4) |
| | c) Differentiate between positive and negative resists. | (5) |
| 3 | a) Write short notes on wet etchants. | (5) |
| | b) Explain the working of a typical CVD reactor with neat diagram. | (6) |
| | c) Compare microelectronics and microsystems. | (4) |

PART B*Answer any two full questions, each carries 15 marks.*

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| 4 | a) Explain the different types of mechanical sensors. | (6) |
| | b) Explain the need for signal processing in MEMS industry. | (4) |
| | c) Explain the working of a microaccelerometer. | (5) |
| 5 | a) Explain the concept of energy conversion and force generation in electromagnetic actuators. | (5) |
| | b) What are the different types of reluctance motors? | (4) |
| | c) Distinguish between sensors, actuators and transducers. | (6) |
| 6 | a) Explain the working of a capacitive type pressure sensor. | (5) |
| | b) Explain the working of an acceleration sensor. | (5) |
| | c) Write short notes on piezoelectric actuators. | (5) |

PART C*Answer any two full questions, each carries 20 marks.*

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| 7 | a) Enlist any four applications of microfluidics. | (4) |
| | b) Explain the various types of mechanical micropumps. | (16) |
| 8 | a) Write down the design constraints in MEMS industry. | (8) |
| | b) Explain the critical consideration factors in the selection of manufacturing process. | (12) |

- 9 a) Explain three levels of microsystem packaging . (10)
- b) Explain modeling and simulation of a typical micropump. (10)
